

1c6894 U.S. PTO  
09/05/00

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A

Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

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1c759 U.S. PTO  
09/05/00  
09/655231

Date: September 5, 2000

Attorney Docket No.: 450100-02694

ASSISTANT COMMISSIONER FOR PATENTS

Box Patent Application

Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Hajime YANO, Hiroaki OISHI, Toyomi FUJINO

entitled:

RECORDING/REPRODUCTION APPARATUS AND RECORDING/REPRODUCTION METHOD

The following are enclosed:

- ☒ Specification ( 55 pages)
- ☒ 8 Sheet(s) of Drawings
- ☒ 16 Claim(s) (including 2 independent claim(s))
- ☐ This application contains a multiple dependent claim

- ☒ Our check for \$ 690.00, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$690.00 (\$345.00)	\$ 690.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each:	-0-
Number of Independent Claims in excess of 3 at \$78.00 (\$39.00) each:	-0-
Multiple Dependent Claim Fee at \$260.00 (\$130.00)	-0-
Total Filing Fee	\$ 690.00
Assignment Recording Fee \$40.00	-0-

- ☒ Oath or Declaration and Power of Attorney

☒ New ☐ signed ☒ unsigned  
☐ Copy from a prior application (37 C.F.R. 1.63(d))

- ☒ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
11-252326	6 September 1999	Japan
2000-134307	28 April 2000	Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP  
Attorneys for Applicants

By William S. Frommer  
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September 5, 2000

Assistant Commissioner for Patents  
Washington, D.C. 20231

Re: U.S. Patent Application  
Applicants: Hajime YANO, Hiroaki OISHI, Toyomi FUJINO  
Our Ref.: 450100-02694


Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,

  
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Enclosures